



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 12, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG756516835

LABORATORY GROWN DIAMOND

OVAL BRILLIANT

9.97 X 7.33 X 4.56 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.10 CARATS

F

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

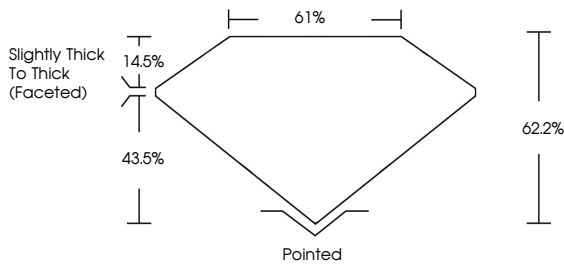
NONE

Inscription(s)

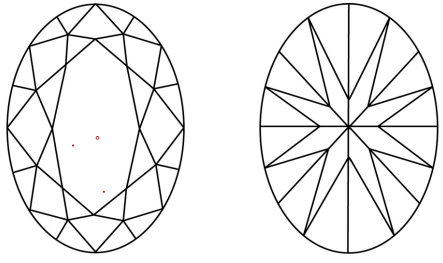
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG756516835

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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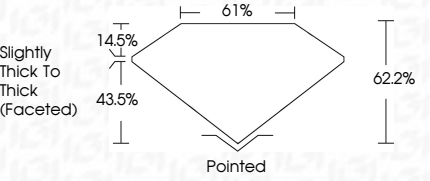
NONE

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PROPORTIONS



COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS<sup>1-2</sup>

VS<sup>1-2</sup>

SI<sup>1-2</sup>

I<sup>1-3</sup>

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

IGI





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December 12, 2025

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OVAL BRILLIANT

9.97 X 7.33 X 4.56 MM

2.10 CARATS

F

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

2.10 CARATS

F

VS 1

62.2%

61%

Slightly Thick To Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

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